

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	2	("4538344").PN.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/07/23 19:05
L3	4114	((438/597) or (438/660) or (438/669) or (438/672) or (438/674) or (438/675) or (438/688)).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/07/23 19:06
L4	2434	3 and (aluminum or aluminium)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/07/23 19:06
L5	427	4 and (via near hole)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/07/23 19:06
L6	172	5 and (diffu\$4 same (silicon or Si))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/07/23 19:08
L7	4972	(aluminum near (thin near (layer of film)))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/07/23 19:07
L8	69	3 and 7	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/07/23 19:07
L9	36	8 and (diffu\$4 same (silicon or Si))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/07/23 19:16
L10	11644	(aluminum same silicon) same (diffu\$4)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/07/23 19:18

L11	9325	10 and (via or contact)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/07/23 19:17
L12	7841	11 and semiconductor	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/07/23 19:17
L13	7002	12 not (@ad>"20030227" or @rlad>"20030227")	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/07/23 19:19
L14	990	((aluminum same silicon) same (diffus\$4)) same via	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/07/23 19:19
L15	871	14 not (@ad>"20030227" or @rlad>"20030227")	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/07/23 19:22
L16	785	15 and semiconductor	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/07/23 19:26
L17	906	(aluminum near silicide)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/07/23 19:22
L18	540	17 and (via or hole)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/07/23 19:22
L19	493	18 not (@ad>"20030227" or @rlad>"20030227")	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/07/23 19:23
L20	428	19 and semiconductor	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/07/23 19:23

L21	6	20 and (aluminum near plug)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/07/23 19:24
L22	22	16 and (aluminum near plug)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/07/23 19:26